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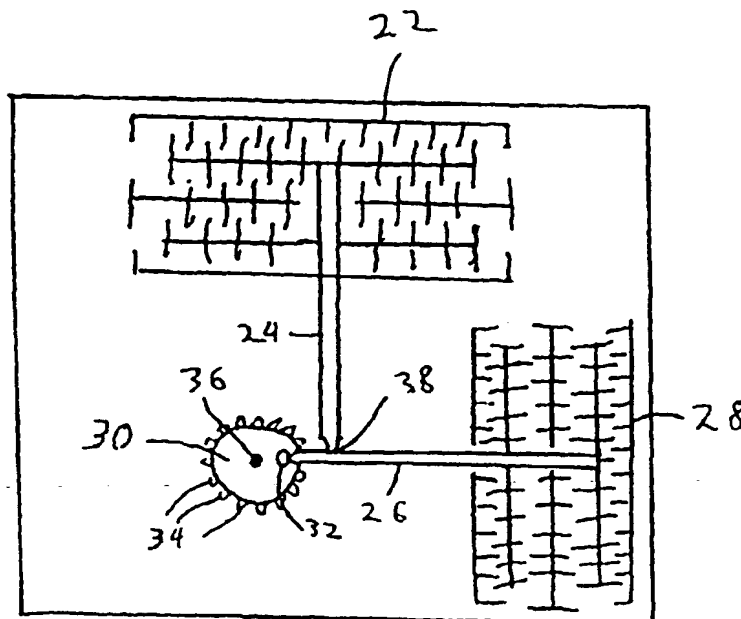
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- (71) Applicant: BOARD OF TRUSTEES OF THE UNIVERSITY OF ARKANSAS [US/US]; 2404 North University Avenue, Little Rock, AR 72207 (US).
- (72) Inventors; and
- (75) Inventors/Applicants (for US only): MALSHE, Ajay, P. [IN/US]; 3043 Summershade Drive, Fayetteville, AR 72701 (US). O'NEAL, Chad [US/US]; 21 Northaven Street, Farmington, AR 72703 (US).
- (74) Agent: KACHIGIAN, Mark, G.; Johnson & Kachigian, 228 West 17th Place, Tulsa, OK 74119 (US).
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(54) Title: APPARATUS AND METHOD FOR NANOSCALE AND MICROSCALE MECHANICAL MACHINING AND PROCESSING

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(57) Abstract: A microscale device provides for a nanoscale machining. A tool, similar to probes used in atomic force microscopy is attached to a micro-load gear and is powered by a micromotor. This very small tool allows a variety of nanostructures to be fabricated on a variety of substrates.

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